

Form PTO-1449 Modified List of Patent and Publications Cited by Applicant (Use several sheets if necessary) U.S. Department of Commerce Patent and Trademark Office	Docket No. N1085-00127		Serial No. Not yet known
	Applicant Yian-Liang Kuo		
	Filing Date 07/09/2003	Group Not yet known	

U. S. PATENT DOCUMENTS

Examiner Initial	Cite No.	Document No.	Kind Code (if known)	Name	Date	Class	Subclass
SA	A	US- 5,626,774		Paulus	05-06-1997	216	47
SA	B	US 6,346,678		Kono et al.	02-12-2002	174	255

FOREIGN PATENT DOCUMENTS

Examiner Initial	Cite No.	Country Code	Number	Kind Code	Publication Date	Name of Patentee or Applicant	Page, Columns, Lines where Relevant Passages Appeal	T

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initial	Cite No.	(Include name of author in CAPITAL LETTERS, Title of the Article (when appropriate) title of the item (book, magazine, journal, symposium, catalog, etc.) date, pages, volume, issue number(s), publisher, city and/or country where published)	T
	C	VLOC (SUBSIDIARY OF H-VI INCORPORATED), "Yttrium Aluminum Garnet Laser Materials"	

EXAMINER Shamim Ahmed	DATE CONSIDERED 3/30/05
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

	D	MICHELLE D. SHINN, "High Average Power Free-Electr n Lasers – A New Laser Source For Materials Processing, Thomas Jefferson National Accelerator Facility, Newport News, VA	
	E	LIGHT AGE, INC. PAL/PRO-UV SCIENTIFIC LASERS, "The All Solid-State Deep UV Laser Source The PAL/PRO – UV™ Laser System" as found at http://www.light-age.com/products/scientific/paluv.html on 7/9/2003	
	F	CIRCUIT TECHNOLOGY CENTER, "Techniques For Removing Solder Mask", as found at html:file://C:\WINNT\Temp\MXLibDir\Feature%20-%204%20Techniques%20for%20R... on 4/29/2003	

EXAMINER	Shamim Ahmed	DATE CONSIDERED	3/30/05
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